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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAWAGUCHI, et al

Serial No.: 10/083,252

Filed: February 27, 2002

For: PLASMA PROCESSING METHOD AND APPARATUS

Group: 1765

Examiner: S. Ahmed

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Mail Stop Non-Fee Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

October 21, 2003

Sir:

In response to the Office Action dated September 24, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Title of the Invention;

Amendment of the Abstract;

Amendments to the Claims; and

Remarks are included following the amendments.